

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/584,160	MURAKAMI, SEISHIRO	
		Examiner	Art Unit	Page 1 of 1
		Cephia D. Toomer	1797	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2004238478	08-2004	Japan		
	O	JP07053974	02-1995	Japan		
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

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